



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: Chang Won CHOI et al. CONF. NO.: 5346
SERIAL NO.: 10/762,526 GROUP: 1763
FILED: 01/23/2004 EXAMINER: Jeffrie Robert LUND
FOR: WAFER ETCHING APPARATUS AND METHOD
DOCKET NO.: 2557-000177/US

RESPONSE TO RESTRICTION REQUIREMENT

Customer Service Window
Randolph Building
401 Dulany Street
Alexandria, VA 22314
Mail Stop Amendment

March 13, 2006

Dear Sir:

Responsive to the Examiner's Restriction Requirement dated December 13, 2006, the following remarks are respectfully submitted in connection with the above-referenced application.

REMARKS

The Examiner required restriction of one of the following inventions:

- I. Claims 1-39, and 44, drawn to an apparatus, classified in class 156, subclass 345.1; and.
- II. Claims 40-43, drawn to a method, classified in class 438, subclass 689.

In response to the Examiner's Restriction Requirement, Applicant elects, with traverse, to prosecute Group I (claims 1-39, and 44). Applicant specifically reserves the right to file a divisional application directed to non-elected claims 40-43.

For all of the above stated reasons, reconsideration and withdrawal of the outstanding restriction/election requirement and favorable allowance of all claims in the instant application are earnestly solicited.

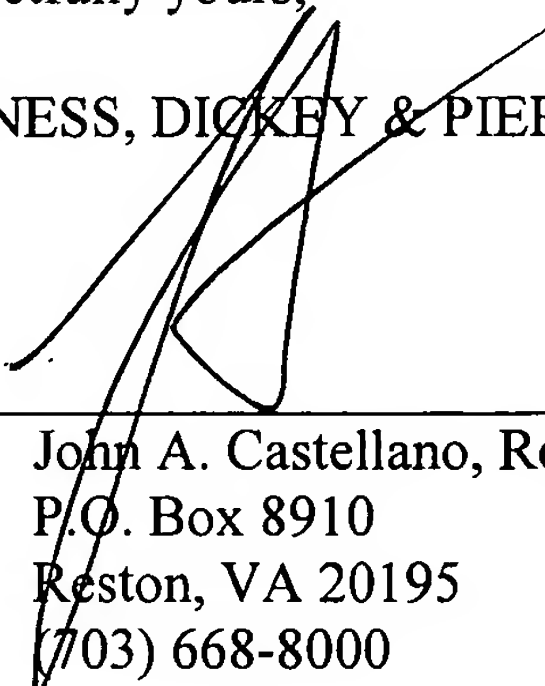
Pursuant to 37 C.F.R. 1.17 and 1.136(a), the Applicants respectfully petition for a two (2) month extension of time for filing a response in connection with the present application, and the required fee of \$450.00 is attached.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies to charge payment or credit any overpayment to Deposit Account No. 08-0750 for any additional fees required under 37 C.F.R. §§ 1.16 or 1.17; particularly, extension of time fees.

Respectfully yours,

HARNESS, DICKEY & PIERCE, PLC

By



John A. Castellano, Reg. No. 35,094
P.O. Box 8910
Reston, VA 20195
(703) 668-8000

JAC:let